Appl. No. 09/929,865 Response dated September 25, 2003 Response to Office Action of June 26, 2003

## LISTING OF THE CLAIMS

1. (Original) An apparatus for creating a molecular array comprising: a base;

a Z controller operably connected to the base wherein the Z controller is selectively positionable along a Z axis;

a deposition probe removably and operably connected to the Z controller so that the deposition probe is selectively positionable along the Z axis by the Z controller;

an X, Y controller operably connected to the base wherein the X, Y controller is selectively positionable along an X axis and a Y axis, the X, Y controller further comprising a deposition substrate operably attached thereto and wherein the movement of the X, Y controller moves the deposition substrate between a first position and a second position, the second position being operably positioned relative to the deposition probe; and

an X, Y translation stage operably connected to the base wherein the X, Y translation stage is selectively positionable along an X axis and a Y axis, the X, Y translation stage further comprising a loading substrate operably attached thereto and wherein the movement of the X, Y translation stage moves the loading substrate between a first position and a second position, the second position being operably located relative to the deposition probe.

- 2. (Original) The apparatus of claim 1 further comprising a control computer.
- 3. (Original) The apparatus of claim 2 further comprising a humidity controller operably attached to the base wherein the humidity controller controls the humidity around the deposition probe.
- 4. (Original) The apparatus of claim 3 wherein the humidity controller is operably connected to the control computer.
- 5. (Original) The apparatus of claim 1 wherein the Z controller has an approximately 200 nanometer spatial resolution along the Z axis.

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- 6. (Original) The apparatus of claim 5 wherein the X, Y controller has an approximately 20 nanometer spatial resolution along the X and Y axes.
- 7. (Original) The apparatus of claim 1 wherein the loading substrate further comprises one or more deposition materials deposited thereon.
- 8. (Original) The apparatus of claim 1 further comprising an optical microscope operably attached to the base.
- 9. (Original) The apparatus of claim 2 further comprising a force feedback monitor.
- 10. (Original) The apparatus of claim 2 wherein the deposition probe further includes a tip.
- 11. (Original) The apparatus of claim 10 further comprising a humidity controller, the humidity controller selectively controlling the humidity of the air around the tip.
- 12. (Original) The apparatus of claim 2 wherein the control computer further comprises a stepper motor control card.
- 13. (Original) The apparatus of claim 12 wherein the humidity controller further comprises a dry gas source, a humidity source, and a gas flow monitor.

14.-16. (Withdrawn)

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17. (Amended) An apparatus for creating an array comprising:

a Z controller;

a deposition probe operably attached to the Z controller, the deposition probe further comprising a tip;

an X, Y controller operably attached to the Z controller; and

a deposition substrate operably affixed to the X, Y controller where the deposition substrate is selectively movable between a first position and a second position and wherein when the X, Y controller moves the deposition substrate to the second position the deposition substrate is operably positioned relative to the tip.

18. (Original) The apparatus of claim 17 further comprising: a control computer operably connected to the Z controller and the X, Y controller;

a force feedback monitor operably affixed to the deposition probe and operably connected to the control computer; and

a humidity controller operably affixed to the Z controller and operably connected to the control computer.

- 19. (Original) The apparatus of claim 20 further comprising an ozone source for cleaning the deposition probe.
  - 20. (Original) An apparatus for creating a deposition domain comprising: an X, Y and Z controller;
    - a loading substrate operably and movably attached to the Z controller;
    - a deposition substrate operably and movably attached to the Z controller;
    - a deposition probe operably attached to the Z controller; and
- a humidity controller operably attached to the Z controller wherein the humidity controller selectively controls the humidity level around the deposition probe, the loading substrate, and the deposition substrate.